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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **MARUYAMA, Kenji, et al.**

Group Art Unit: **2891**

Serial No.: **10/532,249**

Examiner: **FULK, Steven J.**

Filed: **April 22, 2005**

P.T.O. Confirmation No.: 1069

For: **METHOD OF PRODUCING SEMICONDUCTOR DEVICE**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 22, 2008


Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated June 5, 2008, for one month, from September 5, 2008, to October 5, 2008.

Please charge our Deposit Account No. 01-2340 in the amount of \$120.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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DAG/xl

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PATENT & TRADEMARK OFFICE

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